Laser micro-fabrication of concave, low-roughness features in silica

D. Hunger,1 C. Deutsch,2 R. J. Barbour,3 R. J. Warburton,4 and J. Reichel2, a
1Max-Planck-Institut für Quantenoptik and Fakultät für Physik der Ludwig-Maximilians Universität, Schellingstraße 4, D 80799 München, Germany
2Laboratoire Kastler Brossel, ENS/UPMC-Paris 6/CNRS, 24 rue Lhomond, F-75005 Paris, France
3School of Engineering and Physical Sciences, Heriot-Watt University, Edinburgh EH14 4AS, UK
4Department of Physics, University of Basel, Klingelbergstrasse 82, CH-4056 Basel, Switzerland

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We describe a micro-fabrication method to create concave features with ultra-low roughness in silica, either on optical fibers or on flat substrates. The machining uses a single CO2 laser pulse train. Parameters are chosen such that evaporation removes material while a low-viscosity melt layer produces excellent surface quality. A surface roughness $\sigma \sim 0.2 \text{ nm}$ is regularly obtained. The concave depressions are near-spherical close to the center with radii of curvature between 20 and 2000 $\mu$m. The method allows fabrication of low-scatter micro-optical devices such as mirror substrates for high-finesse cavities or negative lenses on fiber tips, extending the range of micro-optical components.

CO2 laser light is a powerful tool for the surface treatment of fused silica. Strong absorption of the 10.6 $\mu$m light within the first few $\mu$m enables controlled surface melting using moderate intensities. A central benefit of such treatment is that surface tension in the molten layer smoothens out surface roughness up to a scale comparable to the thickness of the melt layer. This was recognized as an efficient way to polish optical surfaces.1, 2 Owing to the surface-minimizing effect of the surface tension, melting of large-scale domains which penetrate considerably into the volume will result in the formation of convex structures. While this behaviour has been successfully employed for the fabrication of convex micro-optical structures,3–6 it is undesired in the context of surface polishing. At higher intensities, material removal by evaporation becomes important. In the context of optical surfaces, evaporation has mainly been studied as an unwanted side-effect of damage repair7, 8 and polishing.2 Nevertheless, it holds promise for micro-machining of optical components.9

Here we describe micromachining of concave profiles on silica surfaces in a simple process using a single laser pulse train. We work in a regime where surface evaporation is dominant and shapes a depression, while melting is restricted to a thin layer that smoothens the surface on a short scale. This avoids the need for scanning techniques, special atmospheres, preheating, or polishing pulses. The method allows fabrication of microscopic concave surfaces on the tip of optical fibers as well as on bulk fused silica substrates. It was originally developed to realize high-finesse fiber Fabry-Perot cavities (FFPs) that enabled the first cavity quantum electrodynamics (CQED) experiments with Bose-Einstein condensates,10 and very recently has been used with single organic molecules11 and quantum dots.12 More details on these FFPs can be found in.13, 14 Here, we present an investigation of the physical process leading to the formation of these ultrasmooth concave depressions.

aElectronic address: jakob.reichel@ens.fr

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FIG. 1. (a) Surface profile of a machined fiber measured by the optical profilometer. Beam parameters are $P = 420\,\text{mW}$, $\tau_p = 27\,\text{ms}$ and $w = 28\,\mu\text{m}$. (b) Cut through the center of the profile shown in (a) (red solid line) and its fit to a Gaussian (black dash-dotted line). (c) Central part of the same data (red solid line) along with a circle fitted to the center yielding $R = 70.8\,\mu\text{m}$ (black dash-dotted line). Also shown is the local radius of curvature as calculated from a high-order polynomial fit to the data (green dotted line). (d) Quantities used to characterize the profile. $R$ designates the radius of curvature in the center of the structure. $d$ is the structure diameter as defined in the text and $t$ the depth of the structure.

We use an RF-pumped CO$_2$ laser (Synrad Firestar v20) with a nominal power of 20 W. Pumping is pulsed at 20 kHz, leading to the laser output being pulsed at this rate, as is typical for this type of industrial laser. The average power $P$ is controlled via the duty cycle. Laser power fluctuations are minimized by reducing unwanted back-reflections to the laser with a quarter-wave plate and polarizer, and we obtain energy fluctuations of 1.2% for a 4 ms pulse train. The beam is focussed onto the sample surface. To position the sample with respect to the beam focus, we use a long working distance microscope that allows us to inspect the surface via a dichroic mirror. We estimate the alignment precision to $2\,\mu\text{m}$ transversally and $7\,\mu\text{m}$ along the beam axis, limited by the depth of field of the microscope.

Our substrates are metal-coated, single-mode or gradient-index optical fibers (Oxford Electronics) with 125 and 200 $\mu\text{m}$ cladding diameter, and 2 mm thick fused silica glass plates (Hellma QS). The fibers were not cleaned after cleaving; the plates were roughly cleaned with ethanol. After machining, surfaces were analyzed with several methods. Surface roughness $\sigma_{\text{rms}}$ is evaluated by atomic force microscopy (Dimension 3100 AFM) and optical loss measurements, discussed further below. The overall shape is measured by optical interferometric profiling (Fogale Micromap 3D). Figure 1(a)–1(c) shows a typical machined surface. We observe profiles with an approximately Gaussian shape. The geometrical properties used for characterization are the central radius of curvature $R$, the total depth $t$ and the structure diameter $d$ (Fig. 1(d)). We evaluate $R$ from a polynomial fit to the center of the structure. $t$ is defined as the height difference between the maximum and the minimum elevation, and $d$ as the distance between the turning points from convex to concave curvature of a high-order polynomial fit.

We machined a large set (several hundreds) of fibers, and a series of glass plates, with a broad range of parameters. Laser powers were between $P = 300\,\text{mW}$ and 2 W at the sample surface and pulse trains had durations $\tau_p = 4$ to 120 ms (consisting of 80 to 2400 pulses). Beam waists were between $w = 21$ and 93 $\mu\text{m}$, measured with a moving blade on a motorized translation stage. With these parameters, the resulting structures are $t = 0.01 \ldots 4\,\mu\text{m}$ deep and have diameters of $d = 10 \ldots 60\,\mu\text{m}$, leading to radii of curvature $R = 20 \ldots 2000\,\mu\text{m}$. A characteristic feature of the machining process is its strongly nonlinear power dependence. The data in Fig. 2 illustrates this point. A larger dataset is shown in Fig. 3, where $R$ and $t$ are shown for different powers $P$, waists $w$ and pulse train durations $\tau_p$. For increasing $\tau_p$, the structures become deeper and $R$ becomes smaller. For increasing
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FIG. 2. (a) Central radius of curvature $R$ as a function of pulse train duration $\tau_p$ for various powers $P$. $\varnothing 125 \mu$m fibers were used and the waist was $w = 27 \mu$m. (b) Measured structure depth $t$ as a function of laser power $P$ for $w = 27 \mu$m and three different pulse lengths.

FIG. 3. Experimentally realized geometries: $R$ as a function of $t$. Beam powers and waists: ■ 600 mW, 26 $\mu$m. □ 1.85 W, 73 $\mu$m. ● 373 mW, 27 $\mu$m. ○ 0.9 W, 63 $\mu$m. ▲ 540 mW, 28 $\mu$m. △ 575 mW, 63 $\mu$m. Data for a given parameter set were taken by varying $\tau_p$; $\tau_p$ increases from left to right. Squares: bulk material, circles: $\varnothing 125 \mu$m fiber, triangles: $\varnothing 200 \mu$m fiber. Inset: The measured $R$ agrees well with the value $R_g$ calculated from $d$ and $t$. (Straight line: $R = R_g$.)

$w$, both $d$ and $R$ increase as well. The measured $R$ agrees well with the radius of curvature in the center of a Gaussian characterized by $d$ and $t$, $R_g = d^2/(8t)$ (inset in Fig. 3). This means that only two of the three parameters $\{d, t, R\}$ are independent, the third being fully determined by the other two.

The fiber data show a spread for fixed parameters of up to 13% in the profile depth, 23% in the profile diameter and 13% in the radius of curvature. The fluctuations in laser energy are probably the main reason for this spread. For example, considering the power dependence of $t$ shown in Fig. 2(b) (which is exponential according to the simple model below), the measured power fluctuations of 1.2% lead to fluctuations in $t$ of 10 to 15% for typical parameters.

The possible range of laser parameters for the fabrication of concave profiles is restricted by two physical limits. For very short pulse trains at high intensity, melting and resolidification occur faster than the surface smoothing process.\(^2\) (Our parameters do not reach this limit.) For very long pulse trains, the melt layer extends far into the volume and leads to global contraction into a convex shape. This regime is announced by the formation of a bulge around the depression at our longest
The profile at the end of the pulse is calculated by numerically integrating eq. (2) up to pulse train durations (red dashed curve in Fig. 4(a)). The bulged depressions deviate from a Gaussian shape, becoming shallower and broader.

Some insight into the evaporation process can be gained from a simple model in which the surface temperature profile is used to calculate the ablation rate. The local temperature is calculated from the two-dimensional heat flow equation:

$$\frac{\partial T(r, \tau)}{\partial \tau} = \frac{A w^2 I_0 \sqrt{D}}{2 \sqrt{\pi} \kappa} \int_0^\tau \frac{e^{-r^2w^2/4D\tau'}}{\sqrt{\tau}(w^2/2 + 4D\tau')} \, d\tau'. \tag{1}$$

The temperature in the center can be evaluated analytically, $T(0, \tau) = A I_0 w/(\sqrt{2\pi} \kappa) \arctan(\sqrt{T}/(w^2/8D))$. The material removal rate (velocity of the evaporation front) is related to the local temperature as

$$v(r, \tau) = v_0 e^{-U/(k_B T(r, \tau))}, \tag{2}$$

where $U = 3.6$ eV is the latent heat of evaporation per atom and $v_0 = 3.8 \times 10^5$ cm/s. It becomes significant above $\sim 2000^\circ$C and has a very strong temperature dependence in this temperature range. The profile at the end of the pulse is calculated by numerically integrating eq. (2) up to $\tau = \tau_p$. This simple model neglects all non-linearities, as well as the boundary condition set by the finite size of the fiber that modifies the transverse heat conduction and effects such as the possible recoil pressure produced by the vapor on the molten material.

For short pulse trains (no significant bulge), the depth of the structures is reproduced well by this model (Fig. 4(b)). We treat $\kappa$ as a free fitting parameter on account of its strong temperature dependence; the resulting $\kappa$ values are in the range of published values for hot silica. (The small
difference between the $\kappa$ values for the two fibers is not significant considering the uncertainties of the power and waist measurements.) The observed profile diameters for plate machining are in reasonable agreement with the model. For fiber machining, however, the profile diameters are systematically larger than predicted by the model and also show a different parameter dependence (Fig. 4(c)). A possible explanation is the boundary condition set by the cylindrical geometry of the fiber. The restriction of the transverse heat flow causes heat accumulation and thus leads to an enlarged melt and evaporation area.

The surface roughness is determined by AFM measurements at different positions with scan areas of 0.5, 2 and 5 $\mu$m size to avoid artefacts and to minimize noise. To distinguish between micro roughness, which is important for the optical quality, and the larger scale shape which determines the imaging properties, the deviation from a polynomial fit from each scan line is used for roughness calculations. All measurements show comparable roughness values of $\sigma = 0.24$ nm rms. Fig. 5 shows the residual from this fit and a two dimensional power spectral density calculated from the data (2D PSD). Reference measurements on mica sheets enable us to estimate the noise of the measurement to be $\sigma_{\text{noise}} = 0.1$ nm. Correcting for this yields $\sigma = 0.22$ nm rms for the laser-machined structures, a value approaching that of superpolished optics. Scatter loss can be estimated\(^1\) by $S \approx (4\pi\sigma/\lambda)^2$, which predicts $S \approx 11$ ppm at $\lambda = 830$ nm for this roughness. For two-fiber cavities with state-of-the-art coatings, we have recently obtained a cavity finesse of $F = 100,000$, compatible with the surface roughness result within the uncertainty of the measured cavity transmission.

While traditional mirror superpolishing methods are restricted to large radii of curvature in the centimeter to meter range,\(^18\) the method described here achieves extremely small radii of curvature, and allows a wide range of geometries not limited to the range of data shown here. It thus opens a previously inaccessible geometry regime for high-quality micro-optical lenses and mirrors, starting from low-cost standard substrates. First applications in neutral-atom, quantum dot and molecule CQED\(^10–12,19\) have already shown the power of this method, in realizing microscopic, high-finesse optical cavities with small mode volume. Applications in cavity optomechanics and quantum information experiments with ion traps are under way.

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\(^7\) M. Feit and A. Rubenchik, in Proc. SPIE (2003), vol. 4932, p. 91.